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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inter Patent Application of

N. KOFUJI et al

Serial No. 09/363,191

Group Art Unit: 1763

Filed: July 29, 1999

Examiner: L. Alejandro Mulero

For: DRY ETCHING APPARATUS AND A METHOD OF
MANUFACTURING A SEMICONDUCTOR DEVICE

PETITION FOR EXTENSION OF TIME

Commissioner of Patents
Washington, D.C. 20231

Sir:

It is respectfully requested that a two-month Extension of Time, to and including March 24, 2003, be granted in which to respond to the Final Rejection dated October 24, 2002 and the Advisory Action dated February 4, 2003 in the above-identified application.

Our check including the amount of \$420.00 is attached in payment of the appropriate fee.

The Commissioner is hereby authorized to charge any additional payment due, or to credit any overpayment, to Deposit Account No. 50-1417.

03/25/2003 BNGUYEN1 00000033 09363191

02 FC:1252

410.00 OP


Repin. Ref: 03/25/2003 BNGUYEN1 0008101400

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\$10.00 CR

Respectfully submitted,


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